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CONFIRMATION NO. 9057

<b>SERIAL NUMBER</b> 10/521,425	<b>FILING OR 371(c) DATE</b> 03/22/2005 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2814	<b>ATTORNEY DOCKET NO.</b> 0321.68095
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**\*\* CONTINUING DATA \*\*\*\*\***  
 This application is a 371 of PCT/US03/22608 07/18/2003

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***  
 UNITED STATES OF AMERICA 60397005 07/18/2002  
 UNITED STATES OF AMERICA 60399769 07/31/2002

**\*\* SMALL ENTITY \*\***

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	<b>STATE OR COUNTRY</b> CA	<b>SHEETS DRAWING</b> 8	<b>TOTAL CLAIMS</b> 21	<b>INDEPENDENT CLAIMS</b> 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <u>SAI (4/22/07)</u> Examiner's Signature Initials				

**ADDRESS**  
24978

**TITLE**  
Holographically defined surface mask etching method and etched optical structures

<b>FILING FEE RECEIVED</b> 590	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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